O2/10/0 TEB 1 2005 TEBN

## N THE UNITED STATES PATENT AND TRADEMARK OFFICE

Daniel Alvarez, Jr. and Jeffrey J. Spiegelman

Application No.:

10/692:018

Group:

1724

Filed:

October 23, 2003

Examiner: Frank M. Lawrence, Jr.,

Confirmation No.: 8519

For:

METHOD FOR PURIFICATION OF LENS GASES USED

IN PHOTOLITHOGRAPHY

## CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or is being facsimile transmitted to the United States Patent and Trademark Office on:

2-/0-05 Date

Signature

Typed or printed name of person signing certificate

## CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Please change the correspondence address for the above captioned patent application as follows: All correspondence should be sent to Customer Number 021005, Hamilton, Brook, Smith & Reynolds, P.C., 530 Virginia Road, P.O. Box 9133, Concord, Massachusetts 01742-9133. Please direct all telephone calls to Alice O. Carroll at (978) 341-0036, and all facsimile communications to (978) 341-0136.

Respectfully submitted,

HAMILTON, BROOK, SMITH & REYNOLDS, P.C.

 $\mathsf{By}_{\mathtt{L}}$ 

Charlton Shen

Registration No.: 54,442 Telephone: (978) 341-0036 Facsimile: (978) 341-0136

Concord, MA 01742-9133

Date

10 February 2005